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# Meta-Surface-Wave and Planar Optics

Mingbo Pu Xiaoliang Ma Xiong Li Minghui Hong Changtao Wang Xiangang Luo Editors

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## **Contents**

	Authors
VII	

- ix Symposium Committees
- xi AOMATT 2018 Sponsors

#### META-SURFACE-WAVE AND PLANAR OPTICS

10841 02	Box-like optical filter based on race-track high-order silicon microring resonators [10841-2]
10841 03	Research on angle modulation based on nanohole array fiber optic sensor [10841-4]
10841 04	New insights into Fourier analysis on plane and convex holographic gratings for imaging spectrometers [10841-5]
10841 05	Fast thickness measurement of thin films using two-dimensional Fourier transform-based structured illumination microscopy [10841-6]
10841 06	Simple and rapid particle detection device for substrate surface [10841-9]
10841 07	Investigation of microsphere-assisted super-resolution imaging [10841-10]
10841 08	Super-resolving in telescope imaging system with high Strehl ratio by two-dimensional polynomial phase pupil filter [10841-12]
10841 09	Dual-polarity dielectric cylindrical lens and spherical lens for visible light [10841-13]
10841 0A	Metal nano-honeycomb fabricated by colloidal assembly and femtosecond-laser annealing [10841-15]
10841 OB	High resolution LCD technology for VR [10841-16]
10841 0C	Research review on the development of liquid crystal optical phased array device on the application of free space laser communication [10841-17]
10841 OD	Dynamic three-dimensional shape measurement based on light field imaging [10841-20]
10841 OE	Study on dielectrics and low-temperature viscosity performance of high-frequency difluorovinyl liquid crystals [10841-22]

10841 OF	Lensless in-line holographic microscope resolution enhancement method from two intensity measurements based on data interpolation [10841-23]
10841 0G	Gas flow simulation research on reaction chamber of reactive ion etching [10841-24]
10841 OH	Efficient super-resolution imaging method for micro-nano structure based on structured illumination modulation [10841-26]
10841 01	Flatness and diffractive wavefront measurement of liquid crystal computer-generated hologram based on photoalignment technology [10841-34]
10841 OJ	Plasmonic and metasurface nanostructures for optical imaging [10841-35]
10841 OK	Simulation and experimental research on the uniformity of the surface light source out from the integrating sphere $[10841-48]$
10841 OL	Text paper: research on beaconless spatial acquisition for optical inter-satellite communication [10841-52]
10841 OM	Study on camera calibration method in plane mirror detection system [10841-55]
10841 ON	An aberration-eliminating processing technology for optical window working under differential pressure condition [10841-57]
10841 00	Description of complex optical surface based on sparse radial basis function approximation with spatially variable shape parameters $[10841-68]$
10841 OP	Research of autofocus technology for human fecal microscopic image [10841-70]
10841 0Q	Non-contact measurement of complex surface object volume based on Image processing of double image field $[10841\mbox{-}72]$
10841 OR	Research on the optical system of single-band all-sky airglow imager [10841-75]
10841 OS	Leak rate test method of liquid crystal phase shifter [10841-80]
10841 OT	A survey of wavefront phase inversion algorithms [10841-86]
10841 OU	Analysis of influence of mechanical vibration on ghost imaging [10841-88]
10841 0V	Recent advances in rapid polishing process of large aperture optical flats [10841-94]
10841 OW	Optical processing on the $\phi150mm$ SiC <sub>P</sub> /Al coating nickel phosphorus alloy plane mirror [10841-106]
10841 0X	A variable divergence angle laser beam shaping system with aspherical lenses [10841-112]
10841 OY	Ghost reflection of testing long focal length lens with computer-generated hologram [10841-116]

10841 10	Research of the mist phenomenon on phosphate glass surface [10841-119]
10841 11	Research on interferometric equivalent wavelength of broadband light sources [10841-123]
10841 12	Study on transmission spectrum and electric field distribution of graded-index anti-reflection coatings [10841-215]
10841 13	The design of miniaturization and super wide angle monitor lens based on monocentric lens [10841-221]
10841 14	Design of compact panoramic lens [10841-254]
10841 15	The testing and analysis of accuracy of a large space optical window [10841-305]
10841 16	Research on surface quality measurement technology for small surface structure [10841-306]
10841 17	Research of suppressing stray light of cold shield with different black coating [10841-320]
10841 18	The design of double vision field imaging system based on single lens-reflective structure [10841-352]
10841 19	Study on eliminating the effect of parasitic reflection on deflectometry measurement of planar optical element surface figure [10841-372]
10841 1A	Polarization-insensitive meta-lens doublet with large view field in the ultraviolet region [10841-404]
10841 1B	Characteristics of a mid-wavelength infrared metalenses integrated imaging system [10841-416]
10841 1C	Study on the thermal mismatch strain of CdTe/Si(211) composite substrate [10841-704]
10841 1D	Optimized design of single-plate full-color holographic waveguide display [10841-735]

#### **Authors**

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Ji, Ting, 0W

Ai, Lifu, 06 Bai, Jian, 00 Bao, Jiaqi, 02, 0X Bie, Wenyu, 03 Bin, Fan, OG Bin, Han, OR Cai, Xuanxian, OB Cao, Jun, 10 Chang, Gong, 0G Chen, Binbin, OB Chen, Chuyi, 0H Chen, Guozhao, 0B Chen, Junlin, 17 Chen, Junyi, 0K Chen, Pengyu, 19 Chen, Ting, 0E Chen, Wenjuan, 0S Chen, Xianhua, 0V Chen, Xiaopeng, 15 Chen, Yi, 0U Cheng, Yu-bao, 0U Cheng, Zheng-dong, 0U Cui, Jian-Peng, 0Y Ding, Chengkai, 18 Du, Xiaohui, OP Dun, Aihuan, 10 Fan, Xiang, 0U Feng, Dingyu, 0N Fu, Shihang, Ol Gao, Yang, 1D Ge, Ren, OT Geng, Yidi, 1C Gou, Haoliang, 16 Gu, Zhiyuan, 13 Guan, Jintao, 0E Guo, Hanming, 09 Guo, Hongru, 0C Guo, Rui, 0W Guo, Yinghui, 1A Hang, Lingxia, 12 Hao, Ruaian, OP Hao, Shiqi, OL He, Dewei, 1A Hu, Jinbing, 09 Hu, Song, 05, 07, 0H

Hu, Yao, 01 Huang, Xiao, 00

Huang, Yaolin, 18

Huang, Yidong, 0A

Ji, Zijuan, OX Jiang, Lun, 08 Jiang, Zhuangde, OV Kang, Ming-Wu, 1D Ke, Youlona, 04 Kwok, Hoi Sing, Ol Lee, Byoungho, 0J Lee, Gun-Yeal, 0J Lee, Kyookeun, 0J Li, Bincheng, 0G Li, Dahai, 19 Li, Fanxing, OD, OF Li, Guan-lin, 08 Li, Jing, 0C Li, Junyi, OB Li, Peng, OS Li, Rui-Hua, 1D Li, Xiong, 1A Li, Yong, 04 Li, Zhantao, OR Li, Zhiwei, 0G Li, Zhu, 1A Li, Zuoyin, OB Liao, Defeng, 0V Lin, Feng, 14 Lin, Yuechai, 0A Ling, Ying-chao, 08 Liu, Bingping, OB Liu, Dafu, 17 Liu, Fang, 0A Liu, Jie, OY Liu, Juanxiu, OP Liu, Lin, OP Liu, Manman, 0E Liu, Xi, 05, 07 Liu, Xin, 0G Liu, Xinwu, 0W Liu, Xuanmin, 0W Liu, Yinnian, 04 Liu, Yong, OP Liu, Zhuang, 08 Luo, Lina, 0K Luo, Sha, OK Luo, Xiangang, 06, 1A Luo, Yujie, 00 Ma, Ping, 0Y

Ma, Xiaoliang, 1A

Meng, Xiangyue, 13

Mo, Defeng, 17 Mu, Xingjun, 13 Ni, Guangming, 0P Ouyang, Huiqi, 0E Peng, Fuping, 0D, 0F Peng, Xuhui, OB, OS Pu, Mingbo, 1A Qi, Peng, 0T Qiu, Ze-wen, 0Q Qu, Tuo, 0A Ren, Xiaoli, 0N Shang, Jiyang, 0C Shao, Jianda, 10 Shao, Yajun, 11 Shen, Heliang, 03 Shen, Yizhang, 17 Shi, Hao-dong, 08 Su, Ying, OW Tang, Jinying, OL Tang, Lei, 19 Tang, Shizhen, OK Tang, Yan, 05, 07, 0H Tao, Rongxin, 03 Tian, Peng, OD, OF Tian, Shengnan, 09 Wan, Xiongfeng, OL Wang, Changtao, 06, 1A Wang, Chao, 08 Wang, Chao, 0M Wang, Chen, 00 Wang, Jian, 0V Wang, Lingjie, 1C Wang, Min, 0Q, 18 Wang, Mizhen, 1B Wang, Ruiyang, 19 Wang, Shanshan, 0M, 11 Wang, Shaopu, Ol Wang, Xiangru, OC, 0E Wang, Xiangzhou, OP Wang, Yan, 12 Wang, Yang, 13 Wang, Yang, 17 Wang, Yanqin, 1A Wang, Yuanzhang, 1C Wei, Yanming, 16 Wu, Bo, OS Wu, Xiaoming, 15 Wu, Xiaoxiao, OB Wu, Xin, 1B Xiang, Guang-Xin, 1D Xiao, Yang, OR Xie, Ruiging, 0V Xie, Yi, 1D Xie, Zhongye, 05 Xu, Chenlu, 0L Xu, Hua, 0Y Xu, Kaiyuan, 19 Xu, Lin, 17

Xu, Qiao, 0V Xu, Xiai, 0B Xu, Xueke, 10 Xu, Zengai, 0W Yan, Ding-Yao, 0Y Yan, Wei, OD, OF Yang, Jiao, 0N Yang, Fan, 0D Yang, Fan, OF Yang, Haicheng, 0W Yang, Kejun, 05, 0H Ye, Wen Wei, 14 Yin, Juanjuan, 02 Yu, Muxin, 0N Yu. Han. 0G Yu, Kan, 02 Yu, Tingting, OR Yuan, Yang, 0W Yun, Hansik, OJ Yun, Jeong-Geun, 0J Zang, Jie, 16 Zang, Xiaohua, 16 Zeng, Yanan, OK Zeng, Zhaoqi, 16 Zeng, Zhen Huang, 14 Zhai, Jia, 0N Zhang, Bing, 16 Zhang, Dai, OL Zhang, Fei, 1A Zhang, Feng, 0W Zhang, Jian, 06 Zhang, Jing, OP Zhang, Jingwen, 0G Zhang, Jun, OB Zhang, Keming, 04 Zhang, Linchao, 15 Zhang, Ning, 0Y Zhang, Wanlong, 01 Zhang, Xiaoying, 1C Zhang, Yanchao, 10 Zhang, Yu, 0W Zhang, Zhiyong, 0E Zhao, Wenchuan, 0N Zhao, Huiying, 0V Zhao, Lei, 0O Zhao, Qingsong, 0L Zhao, Shijie, OV Zhao, Xuesen, 16 Zhao, Zeyu, 1A Zheng, Qiusha, 0X Zhou, Xiangdong, 00 Zhou, Yi, 07 Zhu, Bin, OU Zhu, Chao, 0B Zhu, Liu, OT Zhu, Qiudong, 0M, 11

Xu, Min, 04

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